

Notice of References Cited

Application/Control No.

09/739,391

Applicant(s)/Patent Under
Reexamination
READE ET AL.

Examiner

Robert M Kunemund

Art Unit

1765

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,337,991	01-2002	Li et al	505/161
	B	US-6,312,819	11-2001	jia et al	428/450
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Mao et al., "Study on the growth of biaxially aligned yttria-stabilized zirconia films during ion beam assisted deposition", J. vac. Sci. Technolo. A 15(5) sept/Oct 1997 pages 2687-2692
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.